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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/733,977	12/11/2003	Lionel C. Kimerling	MIT.10086	1313
75	590 10/13/2004		EXAMINER	
Matthew E. C		DUPUIS, DEREK L		
Gauthier & Cor Suite 3300	nors LLP		ART UNIT	PAPER NUMBER
225 Franklin St			2883 DATE MAILED: 10/13/2004	
Boston, MA (02110			

Please find below and/or attached an Office communication concerning this application or proceeding.

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• .	Application No.	Applicant(s)					
Office Antique Comment	10/733,977	KIMERLING ET AL.					
Office Action Summary	Examiner	Art Unit					
	Derek L Dupuis	2883					
The MAILING DATE of this communication Period for Reply	n appears on the cover sheet w	ith the correspondence address					
A SHORTENED STATUTORY PERIOD FOR R THE MAILING DATE OF THIS COMMUNICAT! - Extensions of time may be available under the provisions of 37 C after SIX (6) MONTHS from the mailing date of this communicati. - If the period for reply specified above is less than thirty (30) days - If NO period for reply is specified above, the maximum statutory - Failure to reply within the set or extended period for reply will, by Any reply received by the Office later than three months after the earned patent term adjustment. See 37 CFR 1.704(b).	ION. ER 1.136(a). In no event, however, may a on. , a reply within the statutory minimum of thi period will apply and will expire SIX (6) MOI statute, cause the application to become A	reply be timely filed ty (30) days will be considered timely. NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133)					
Status							
1) Responsive to communication(s) filed on							
2a) This action is FINAL . 2b)	This action is non-final.						
	,— ,,						
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims							
4)⊠ Claim(s) <u>1-16</u> is/are pending in the applic	ation.						
4a) Of the above claim(s) is/are wit	hdrawn from consideration.						
5)⊠ Claim(s) <u>1-16</u> is/are allowed.							
6) Claim(s) is/are rejected.							
7) Claim(s) is/are objected to.	and the state of t						
8) Claim(s) are subject to restriction a	and/or election requirement.						
Application Papers							
9)⊠ The specification is objected to by the Exa	miner.						
10)⊠ The drawing(s) filed on <u>12/11/2003</u> is/are:	10)⊠ The drawing(s) filed on <u>12/11/2003</u> is/are: a)⊡ accepted or b)⊠ objected to by the Examiner.						
Applicant may not request that any objection t	- · ·	• •					
Replacement drawing sheet(s) including the c).				
11) ☐ The oath or declaration is objected to by the	ne Examiner. Note the attache	d Office Action or form PTO-152.					
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for fo a) All b) Some * c) None of:		§ 119(a)-(d) or (f).					
1. Certified copies of the priority docu							
2. Certified copies of the priority docu3. Copies of the certified copies of the							
 Copies of the certified copies of the application from the International B 		received in this National Stage					
* See the attached detailed Office action for		received					
		· · · • • ·					
Attachment(s)							
1) ☑ Notice of References Cited (PTO-892) 2) ☑ Notice of Draftsperson's Patent Drawing Review (PTO-94	4) Interview	Summary (PTO-413) s)/Mail Date					
 Notice of Dransperson's Patent Drawing Review (PTO-94) Information Disclosure Statement(s) (PTO-1449 or PTO/S Paper No(s)/Mail Date 7/9/04 & 12/11/03. 		nformal Patent Application (PTO-152)					

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DETAILED ACTION

Allowable Subject Matter

- 1. Claims 1-16 are allowed.
- 2. The following is an examiner's statement of reasons for allowance: Claims 1-16 are allowable over the prior art of record because the latter, either alone or in combination, does not disclose nor render obvious a waveguide-semiconductor device comprising a waveguide structure with a multimode interferometer structure that minimizes the reflections of TE modes and a mesa structure that is coupled to the waveguide structure that minimizes the reflections of TM modes in combination with the rest of the claimed limitations.
- 3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

- 4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. *Hamamoto (US 2001/0021299 A1)* teaches a semiconductor waveguide photodetector that strongly confines the TE and TM modes. However, Hamamoto does not teach that these modes are confined by a multimode interferometer structure or a mesa structure. *Yang (US 6,778,723 B1)* teaches an integrated optical switch with a mesa structure and optical detector comprising germanium. However, Yang does not teach that detector and the mesa structure are separate components of the invention as claimed by the applicant.
- 5. This application is in condition for allowance except for the following formal matters:

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6. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(4) because reference characters "20" and "22" have both been used to designate the coupling device.

Reference characters "20" and "26" have both been used to designate the Si layer.

- 7. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(4) because reference character "16" has been used to designate both the upper cladding and the lower cladding in line 13 of page 5. Reference character "22" has also been used to designate both the SiNx waveguide and the coupling device. Reference character "20" has also been used to designate both the Si layer and the coupling device.
- 8. The drawings are objected to because figures 2A, 2B, 5A, and 5B are too dark to properly discern the features of the drawings.
- 9. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(5) because they do not include the following reference sign(s) mentioned in the description: 2 and 20.
- 10. The drawings are objected to under 37 CFR 1.83(a). The drawings must show every feature of the invention specified in the claims. Therefore, the multimode interferometer must be shown or the feature(s) canceled from the claim(s). No new matter should be entered.
- 11. Corrected drawing sheets in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. The figure or figure number of an amended drawing should not be labeled as "amended." If a drawing figure is to be canceled, the appropriate figure must be removed from the replacement sheet, and where necessary, the remaining figures must be renumbered and appropriate changes made to the brief description of the several views of the

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drawings for consistency. Additional replacement sheets may be necessary to show the renumbering of the remaining figures. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.84(c)) so as not to obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

- 12. The disclosure is objected to because of the following informalities: the phrase "would be an inefficient to be used in" in line 22 of page 2 should apparently read "would be inefficient in". The word "improve" in line 11 of page 4 should apparently be "improved". The phrase "growth facets" in line 21 of page 5 should apparently be "growth facets of". The phrase "growth facet" in line 22 of page 5 should apparently be "a growth facet of". The phrase "will address this issue more issue hereinafter" in line 7 of page 6 should apparently be "will address this issue more hereinafter". The phrase "the detector is also formed on the Si layer 26" in line 14 of page 7 should apparently be "the detector 26 is also formed on the Si layer 28". The phrase "coupling 20" in line 22 of page 7 should apparently be "coupling device 20".
- 13. The informalities above are given as examples as there are too many informalities in the application to list in this office action. The applicant is advised to review the specification and the drawings and make additional corrections as needed. The applicant is advised to pay specific attention to the use of reference numbers throughout the specification with regards to the objections to the drawings noted above. Appropriate correction is required.
- 14. Prosecution on the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

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A shortened statutory period for reply to this action is set to expire **TWO MONTHS** from the mailing date of this letter.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Derek L Dupuis whose telephone number is (571) 272-3101. The examiner can normally be reached on Monday - Friday 8:30am-4:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Frank G. Font can be reached on (571) 272-2415. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Derek L. Dupuis

Examiner

Group Art Unit 2883

Supervisory Patent Examiner Technology Center 2800